

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Bipin S. Parekh, Jeffrey J. Spiegelman, Robert S. Zeller and Russell J. Holmes

Application No.: 10/565,486 Group: 1797

Filed: May 4, 2006 Examiner: Jason M. Greene

Confirmation No.: 2074

For: LITHOGRAPHIC PROJECTION APPARATUS, PURGE GAS SUPPLY SYSTEM AND GAS PURGING METHOD

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This Amendment is being filed in response to the Office Action mailed from the U.S. Patent and Trademark Office on July 20, 2009 in the above-identified application. Reconsideration and further examination are requested.

Please amend the application as follows: